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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/821,491	04/09/2004	Sergei Drizlikh	P05842	1426	
23990 7	590 06/29/2005		EXAMINER		
DOCKET CLERK			GURLEY, LYNNE ANN		
P.O. DRAWER 800889 DALLAS, TX 75380			ART UNIT	PAPER NUMBER	
,			2812	2812	
			DATE MAILED: 06/20/2006	5	

Please find below and/or attached an Office communication concerning this application or proceeding.

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			Application No.	Applicant(s)			
Office Action Summary			10/821,491	DRIZLIKH ET AL.			
		E	Examiner	Art Unit			
			ynne A. Gurley	2812			
Period fo	The MAILING DATE of this communion Reply	ication appea	rs on the cover sheet with the c	orrespondence address			
THE - Exte after - If the - If NO - Failt Any	ORTENED STATUTORY PERIOD FOR MAILING DATE OF THIS COMMUNI INSIGNS of time may be available under the provisions SIX (6) MONTHS from the mailing date of this comme period for reply specified above its less than thirty (3) period for reply is specified above, the maximum stature to reply within the set or extended period for reply reply received by the Office later than three months a ed patent term adjustment. See 37 CFR 1.704(b).	CATION. of 37 CFR 1.136(a unication. o) days, a reply withtutory period will a will, by statute, ca	a). In no event, however, may a reply be tim thin the statutory minimum of thirty (30) days apply and will expire SIX (6) MONTHS from use the application to become ABANDONEI	nely filed s will be considered timely. the mailing date of this communication. D (35 U.S.C. § 133).			
Status							
1) 🏻	Responsive to communication(s) file	d on <i>02 Mav</i>	2005.				
· · · · ·	•		ction is non-final.				
3)	<u> </u>						
٥,۵	closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.						
Disposit	ion of Claims	·					
_							
4)[✓ Claim(s) <u>1-12</u> is/are pending in the application. 4a) Of the above claim(s) <u>5-12</u> is/are withdrawn from consideration. 						
5\□	Claim(s) is/are allowed.						
•							
7)	☑ Claim(s) <u>1-4</u> is/are rejected. ☑ Claim(s) is/are objected to.						
′	Claim(s) are subject to restrict	tion and/or e	election requirement				
•							
_	ion Papers						
9)☐ The specification is objected to by the Examiner.							
10)	10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.						
	Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).						
44)	Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d). 11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.						
11)[The oath or declaration is objected to	by the Exam	niner. Note the attached Office	Action or form PTO-152.			
Priority (under 35 U.S.C. § 119						
•	Acknowledgment is made of a claim ☐ All b)☐ Some * c)☐ None of:	for foreign pr	riority under 35 U.S.C. § 119(a)	-(d) or (f).			
	1. Certified copies of the priority documents have been received.						
2. Certified copies of the priority documents have been received in Application No							
	· · · · · · · · · · · · · · · · · · ·	, ,	documents have been receive	ed in this National Stage			
application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received.							
- June A. Henry							
				LYNNE A. GURLEY			
Attachmen	t(s)		. PF	RIMARY PATENT EXAMINER			
	e of References Cited (PTO-892)		4) Interview Summary	TC 2800, AU 2812 (PTO-413)			
2) Notic	e of Draftsperson's Patent Drawing Review (P		Paper No(s)/Mail Da	ate			
	mation Disclosure Statement(s) (PTO-1449 or r No(s)/Mail Date	PTO/SB/08)	5)	atent Application (PTO-152)			
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DETAILED ACTION

Election/Restrictions

1. Applicant's election with traverse of claims 1-4 in the reply filed on 5/2/05 is acknowledged. The traversal is on the ground(s) that the two species are related. This is not found persuasive because the embodiment containing the conversion of the Ti to TiN does not have to be applied to prevention of a contaminant within a layer of ARC.

The requirement is still deemed proper and is therefore made FINAL.

Specification

2. The specification has not been checked to the extent necessary to determine the presence of all possible minor errors. Applicant's cooperation is requested in correcting any errors of which applicant may become aware in the specification.

Claim Rejections - 35 USC § 102

3. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 4. Claim1 is rejected under 35 U.S.C. 102(b) as being anticipated by Mueller et al. (US 5,427,666, dated 6/27/95).

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Mueller shows the method as claimed in figure 3B and corresponding text, with TiN (ARC) 58 and Ti layer 60, which protects the layer 58 from contaminants. Nitrogen plasma is used to form the TiN.

Claim Rejections - 35 USC § 103

- 5. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 6. The factual inquiries set forth in *Graham* v. *John Deere Co.*, 383 U.S. 1, 148 USPQ 459 (1966), that are applied for establishing a background for determining obviousness under 35 U.S.C. 103(a) are summarized as follows:
 - 1. Determining the scope and contents of the prior art.
 - 2. Ascertaining the differences between the prior art and the claims at issue.
 - 3. Resolving the level of ordinary skill in the pertinent art.
 - 4. Considering objective evidence present in the application indicating obviousness or nonobviousness.
- 7. This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

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8. Claims 2-4 are rejected under 35 U.S.C. 103(a) as being unpatentable over Mueller et al. (US 5, 427,666, dated 6/27/95) in view of Ting et al. (US 6,399,508, dated 6/4/02).

Mueller shows the method substantially as claimed and as described in the previous paragraphs.

Mueller lacks anticipation only in not teaching that the contaminant may be fluorine and that the application of the nitrogen plasma increases a temperature of the semiconductor device to approx. 400 degrees C.

Ting teaches etching of Ti and TiN in a fluorine atmosphere to pattern the layers.

It would have been obvious to one or ordinary skill in the art that the Ti layer over the TiN ARC, as taught in Mueller, would protect the TiN layer from the damage caused by subsequent patterning using fluorine, with the motivation that the Ti layer would act as a barrier to the fluorine atoms.

It would have been obvious to one of ordinary skill in the art to have increased a temperature of the semiconductor device to approx. 400 degrees C by the application of the nitrogen plasma, in the method of Muealler, with the motivation that the plasma nitridation process may be performed conventionally while heating the substrate to such a temperature.

Conclusion

9. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. See the PTO Form 892.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Lynne A. Gurley whose telephone number is 571-272-1670. The examiner can normally be reached on M-F 7:30-4:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Michael Lebentritt can be reached on 571-272-1873. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Lynne A. Gurley

Primary Patent Examiner

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LAG

June 27, 2005